FIG.1A

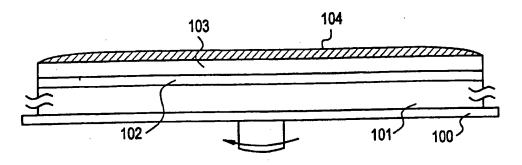


FIG.1B

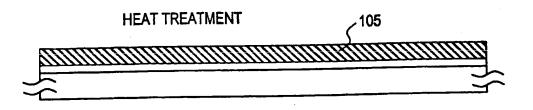


FIG.1C

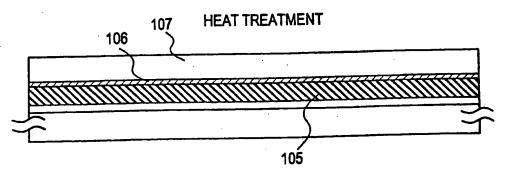


FIG.1D

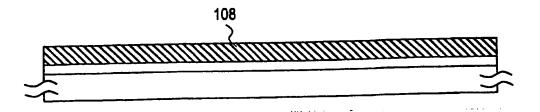


FIG.2

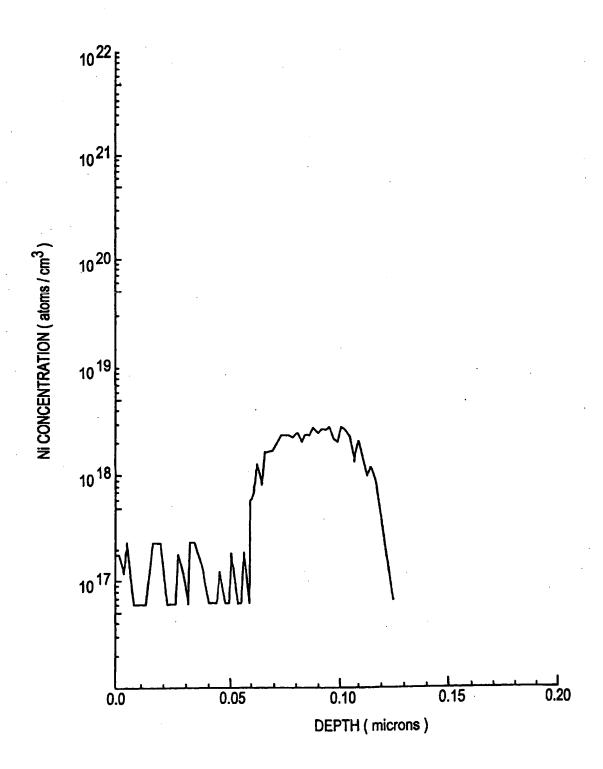


FIG.3

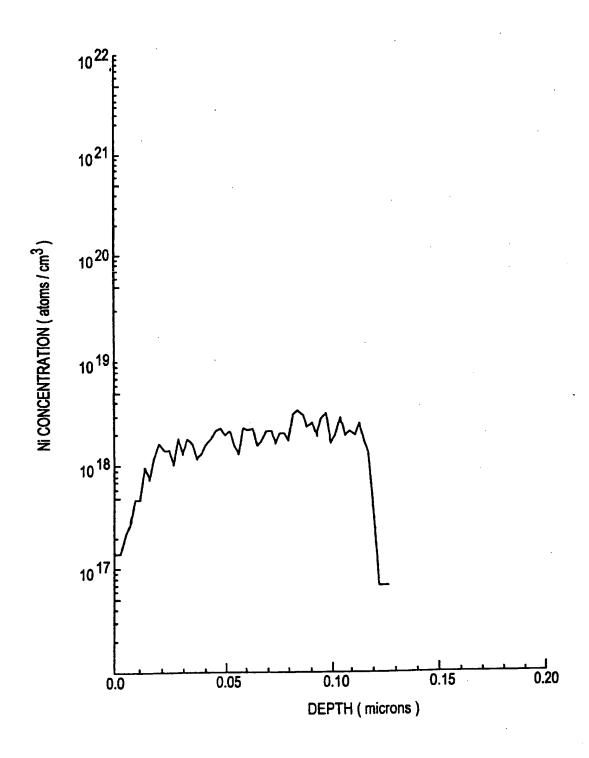


FIG.4

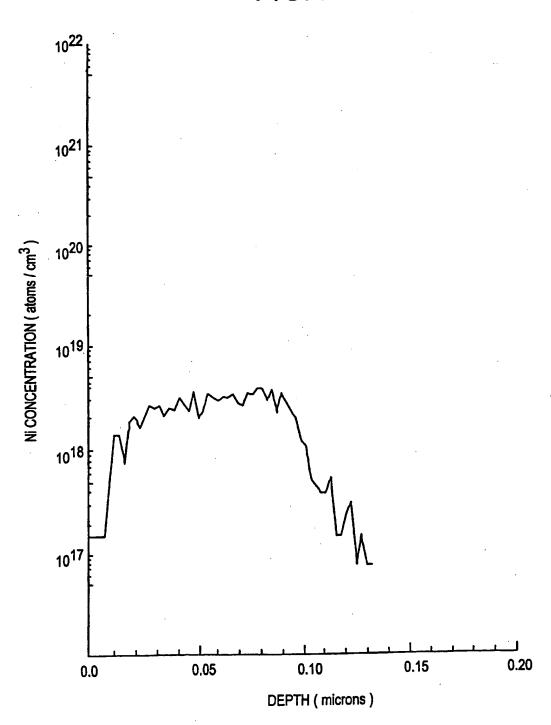


FIG.5A

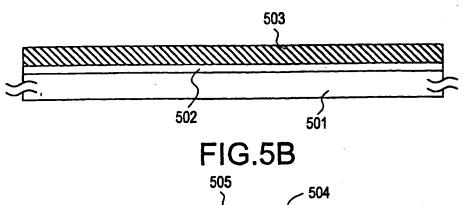


FIG.5C

IMPURITY ION IMPLANTATION AND LASER LIGHT IRRADIATION

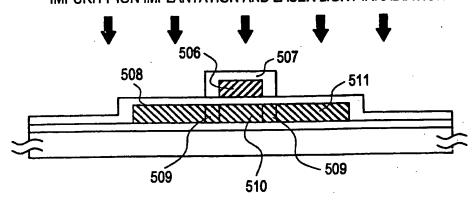


FIG.5D

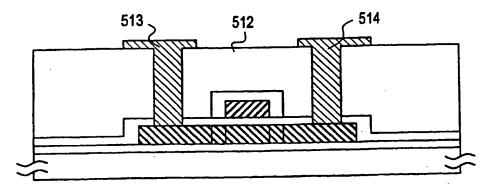


FIG.6A

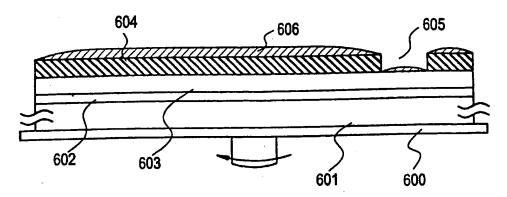


FIG.6B

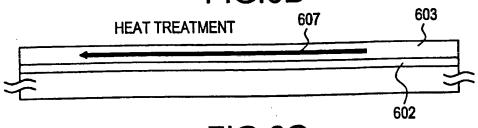


FIG.6C

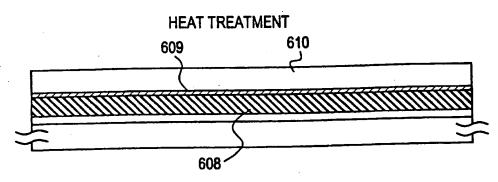


FIG.6D

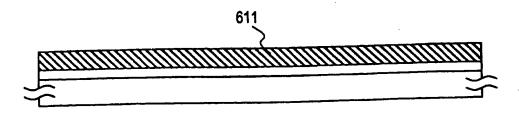


FIG.7A

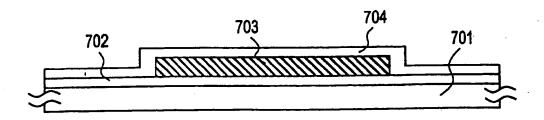


FIG.7B

IMPURITY ION IMPLANTATION AND LASER LIGHT IRRADIATION

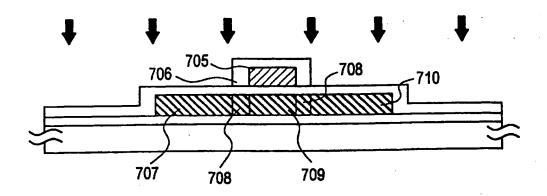


FIG.7C

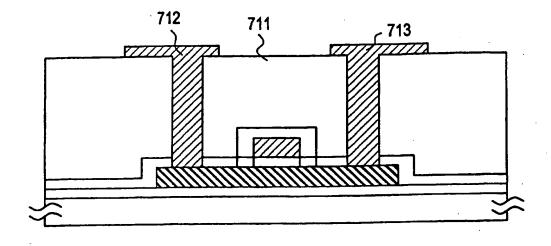


FIG.8A

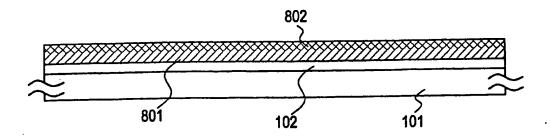


FIG.8B

HEAT TREATMENT

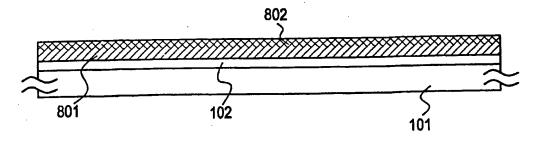


FIG.8C

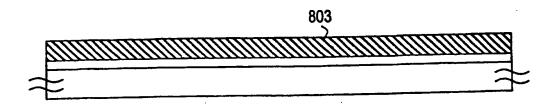


FIG.9A

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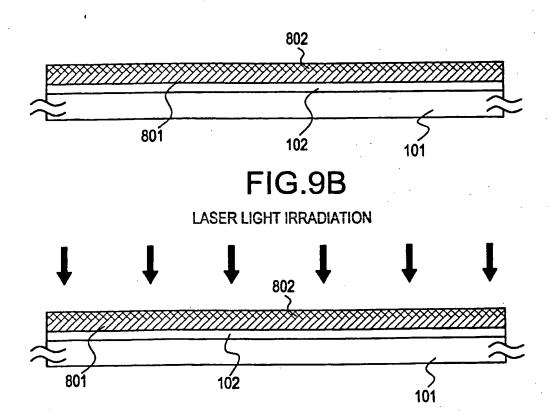


FIG.9C

